

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Application of)
Shunpei YAMAZAKI et al.)
Based On Application No. 09/838,216) Art Unit: 2824
Which Was Filed: April 20, 2001) Examiner: M. Lebentritt
For: METHOD FOR FABRICATING)
SEMICONDUCTOR THIN FILM) Date: October 6, 2003

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please preliminarily amend the subject application as follows: